

Refine Search

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Terms	Documents
(micromirror\$1 or mirror\$1 or microelectromechanical) NEAR10 substrate SAME (wir\$3 or electronic\$4 or circuit\$2) NEAR10 substrate SAME pattern\$3 SAME (detect\$3 or sens\$3) SAME angle\$1	4

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	DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=OR		
<u>L10</u>	(micromirror\$1 or mirror\$1 or microelectromechanical) NEAR10 substrate SAME (wir\$3 or electronic\$4 or circuit\$2) NEAR10 substrate SAME pattern\$3 SAME (detect\$3 or sens\$3) SAME angle\$1	4	<u>L10</u>
<u>L9</u>	(micromirror\$1 or mirror\$1 or microelectromechanical) NEAR10 substrate SAME (wir\$3 or electronic\$4 or circuit\$2) NEAR10 substrate SAME pattern\$3 SAME (detect\$3 or sens\$3)	33	<u>L9</u>
<u>L8</u>	(micromirror\$1 or mirror\$1 or microelectromechanical) SAME substrate SAME (wir\$3 or electronic\$4 or circuit\$2) SAME substrate SAME pattern\$3 SAME (detect\$3 or sens\$3)	236	<u>L8</u>
<u>L7</u>	micromirror\$1 SAME substrate SAME (wir\$3 or electronic\$4 or circuit\$2) SAME substrate SAME pattern\$3 SAME (detect\$3 or sens\$3)	1	<u>L7</u>
<u>L6</u>	micromirror\$1 NEAR10 substrate SAME (wir\$3 or electronic\$4 or circuit\$2)	0	<u>L6</u>

	NEAR10 substrate SAME pattern\$3 SAME (detect\$3 or sens\$3) micromirror\$1 NEAR10 substrate SAME (wir\$3 or electronic\$4 or circuit\$2)		
<u>L5</u>	NEAR10 substrate SAME pattern\$3 SAME (electroconductive or conductive) SAME (detect\$3 or sens\$3) micromirror\$1 NEAR10 substrate SAME (wir\$3 or electronic\$4 or circuit\$2)	0	<u>L5</u>
<u>L4</u>	NEAR10 substrate SAME pattern\$3 SAME (electroconductive or conductive) WITH (spacer\$1 or post\$1 or column\$1) micromirror\$1 NEAR10 substrate SAME (wir\$3 or electronic\$4 or circuit\$2)	1	<u>L4</u>
<u>L3</u>	NEAR10 substrate SAME pattern\$3 SAME (detect\$3 or sens\$3) SAME angle\$1 micromirror\$1 NEAR10 substrate SAME (wir\$3 or electronic\$4 or circuit\$2)	0	<u>L3</u>
<u>L2</u>	NEAR10 substrate SAME pattern\$3 SAME (detect\$3 or sens\$3) WITH angle\$1 micromirror\$1 NEAR10 substrate SAME (wir\$3 or electronic\$4 or circuit\$2)	0	<u>L2</u>
<u>L1</u>	NEAR10 substrate SAME pattern\$3	29	<u>L1</u>

END OF SEARCH HISTORY.